



In re Application of:  
Shang, et al.

Serial No.: 09/741,529

Confirmation No.: 6382

Filed: December 19, 2000

For: On Site Cleaning Gas  
Generation for Process  
Chamber Cleaning

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Group Art Unit: 1746

**Examiner: Michail Kornakov**

Dear Sir:

**CERTIFICATE OF MAILING**  
37 CFR 1.8

I hereby certify that this correspondence is being deposited on  
April 16, 2004 with the United States Postal Service as First  
Class Mail in an envelope addressed to: Commissioner for  
Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

4/16/04 *Kevin R. [Signature]*

Date Signature

**RESPONSE TO OFFICE ACTION DATED JANUARY 16, 2004**

In response to the Office Action dated January 16, 2004, having a shortened statutory period for response set to expire on April 16, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicants believe that no fee is due, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5434.Y2/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 6 of this paper.